



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1430  
 Alexandria, Virginia 22313-1430  
 www.uspto.gov



8th Date Sheet

CONFIRMATION NO. 6875

SERIAL NUMBER 10/633,682	FILING DATE 08/05/2003  RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 116507
-----------------------------	---------------------------------------	--------------	------------------------	----------------------------------

## APPLICANTS

Takunori Iki, Suwa-shi, JAPAN;

Tomohiko Hayashi, Chino-shi, JAPAN;

\*\* CONTINUING DATA \*\*\*\*\*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2002-238483 08/19/2002

JAPAN 2003-195081 07/10/2003

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 10/31/2003

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 11	TOTAL CLAIMS 15	INDEPENDENT CLAIMS 4
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Verification and Acknowledged Examiner's Signature: <i>[Signature]</i> Initials: <i>[Initials]</i>				

## ADDRESS

25944

OLIFF &amp; BERRIDGE, PLC

P.O. BOX 19928

ALEXANDRIA, VA

22320

## TITLE

System and method of manufacturing a substrate device

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
RECEIVED		